



03500.014286.

PATENT APPLICATION

# 17/IDS  
7/24/03  
C. Per

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: A. Alavi  
HIDEAKI MITSUTAKE ET AL. )  
: Group Art Unit: 2875  
Appln. No.: 09/512,359 )  
:   
Filed: February 24, 2000 )  
:   
For: ELECTRON BEAM APPARATUS ) June 24, 2003

Mail Stop DD  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RECEIVED  
JUL - 1 2003  
TECHNOLOGY CENTER 2800

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 24, 2003.

(Date of Deposit)

FRANK A. DeLUCIA, JR. (REG. #42,476)

(Name of Attorney for Applicant)

Signature

June 24, 2003

Date of Signature

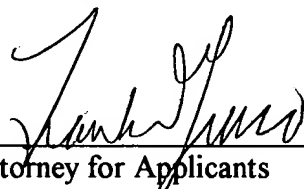
documents are also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicants

Registration No. 42,476

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